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APPLICANTS

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**** CONTINUING DATA *******

This application is a 371 of PCT/JP03/14673 11/18/2003

**** FOREIGN APPLICATIONS *******

JAPAN 2002-346138 11/28/2002

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|---|---------------------------|----------------------|--------------------|-------------------------|
| Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no | STATE OR COUNTRY JAPAN | SHEETS DRAWING 16 | TOTAL CLAIMS 12 | INDEPENDENT CLAIMS 4 |
| 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance | | | | |
| Verified and Acknowledged Examiner's Signature _____ Initials _____ | | | | |

ADDRESS

23353

TITLE

Wafer processing system, coating/developing apparatus, and wafer, processing apparatus

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| FILING FEE RECEIVED 1460 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit |
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